

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Kenichi KOYANAGI et al.

New York, New York

Serial No.: 10/630,444

Date: June 20, 2006

Filed: July 29, 2003

Group Art Unit: 2812

Examiner:

For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art cited in a communication from a foreign patent office in a counterpart foreign application, together with a form listing the same for the convenience of the Examiner. A translation of relevant parts of the Office Action has been provided in lieu of a Statement of Relevancy of the present invention to the teachings of the teachings of the cited prior art.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in connection with a corresponding patent application not more than three months prior to the filing of this Submission.

I respectfully request that the information submitted be considered and enclose our check number 24933 in payment of the required \$180.00 fee.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on June 20, 2006

Max Moskowitz

Name of applicant, assignee or
Registered RepresentativeSignature
June 20, 2006

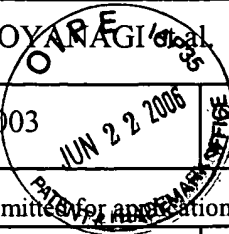
Date of Signature

Respectfully submitted,

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APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/630,444		OFGS File No. P/3236-39	
		Applicant Kenichi KOYAMA et al.			
		Filing Date July 29, 2003		Group Art Unit 2812	



U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-2002/0086476	07-2002	Kim, et. al.			
	US-					
	US-					
	US-					
	US-					
	US-					
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	US-					
	US-					

FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	9-77593	03-1997	Japan				X
	2001-220676	08-2001	Japan				X
	2001-160616	06-2001	Japan				X
	2001-127258A	05-2001	Japan				X
	9-121035	05-1997	Japan				X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
		Untranslated Office Action issued by Japanese Patent Office on March 22, 2006 in connection with corresponding application no. 2002-220468
		English translation of relevant portions of Examiner's comments in Japanese Office Action issued 03/22/06 submitted in lieu of statement of relevancy of prior art to present invention

Examiner	Date Considered
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.